

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re: Russell et al.

Serial No.: To Be Assigned

Filed: Concurrently Herewith

For: CHEMICALLY ENHANCED FOCUSED ION BEAM MICRO-MACHINING OF COPPER

September 26, 2003

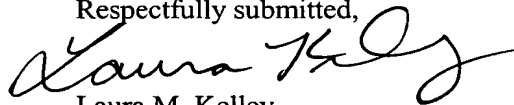
Mail Stop Patent Application  
Commissioner for Patents  
PO Box 1450  
Alexandria, VA 22313-1450

**INFORMATION DISCLOSURE STATEMENT**

Sir:

Attached is a list of documents on form PTO-1449. Items 1-10 listed on the PTO-1449 were cited in parent application Serial No. 10/284,784, filed October 31, 2002. Since the benefit of this application is claimed under 35 U.S.C. § 120, no copies need to be furnished in accordance with 37 C.F.R. § 1.98(d); however, copies will be furnished on request. It is requested that these documents be considered by the Examiner and officially made of record in accordance with the provisions of 37 C.F.R. § 1.97 and Section 609 of the MPEP. The Commissioner is hereby authorized to charge any additional fee, which may be required, or credit any refund, to our Deposit Account No. 50-0220.

Respectfully submitted,



Laura M. Kelley

Registration No. 48,441

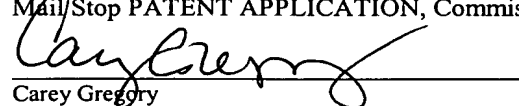
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I hereby certify that this correspondence is being deposited with the United States Postal Service "Express Mail Post Office to Addressee" service under 37 CFR § 1.10 on the date indicated above and is addressed to:  
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Carey Gregory

Examiner: \_\_\_\_\_ Date Considered: \_\_\_\_\_

**Examiner:** Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.